

# Development of a 3D motion sensor module

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**Abstract:** This paper presents a development of a 3D motion sensor IC which detects inertial movements and earth's magnetic fields for a compass heading. It consists of a 3-axis accelerometer, a 2-axis geomagnetic sensor, and a microcontroller. An automatic calibration and measurement system is developed to reduce test lead time. For the geomagnetic sensor part, an accuracy of  $\pm 5$  degrees, a resolution of  $\pm 1$  degrees, and a linearity of  $\pm 1$  % in full scale range have been achieved. The accelerometer has a full measurement range of  $\pm 2g$ . Both sensitivity of 819 count/g with a 12-bit analog-to-digital converter and a linearity of  $\pm 0.5\%$  in full scale have been achieved. While driving voltage can operate between 2.7 and 3.3 V, current consumption is 3.2 mA at 2.8 V. Thorough reliability test is performed and the sigma level of geomagnetic sensor heading accuracy is 5.6, and that of accelerometer sensitivities are 4.6, 5.6, and 4.5 for x, y, and z axis respectively. The dimension of a packaged chip is 8.3 mm  $\times$  5.3 mm  $\times$  1.5 mm. © 2006 IEEE.

Year: 2006

Source title: Proceedings of IEEE Sensors

Art. No.: 4178708

Page : 666-670

Link: Scopus Link

Document Type: Conference Paper

Source: Scopus

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